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				Application Number	10/517,491	
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5				Group Art Unit		
				Examiner Name		
				Confirmation No.	5564	
Sheet	1	of	3	Attorney Docket Number	2732-149	

U.S. PATENT DOCUMENTS							
		U.S. Patent Do	cument		Name of Patentee or Applicant	Date of Publication	
Examiner Initials*	Cite No.1	Number	Kind ((if kno	Code² wn)	Name of Patentee or Applicant of Cited Document	of Cited Document MM-DD-YYYY	
	1	6,088,161			Lee	06-11-2000	
	2	5,825,547			Lee	10-20-1998	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code. ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				First Named Inventor	KAULE	
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Sheet		of	3	Attorney Docket Number	2732-149	

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Examiner Initials*	Cite No.1	Office ³ Code	Number⁴	Kind ⁵ (if known)	Name of Paten Cited	ntee or Applicant Document	Date of Publication of Cited Document MM-DD-YYYY T ⁶
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				Confirmation No.	5564
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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	4	RAI-CHOUDHURY, P., "SPIE handbook of microlithography, micromachining and microfabrication", Handbook of Microlithography, Section 2.5 Systems, 16 pages,	
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